

APR 30 2003

AMENDMENT TRANSMITTAL LETTER

Docket No.
M4065.0466/P466Application No.
09/938,644-Conf. #1172Filing Date
August 27, 2001Examiner
T. MackeyArt Unit
1765

Applicant(s): Neal Rueger

Invention: METHOD AND APPARATUS FOR MICROMACHINING USING A MAGNETIC FIELD AND PLASMA ETCHING

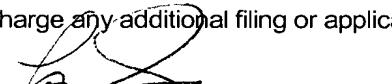
TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

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| CLAIMS AS AMENDED | | | | | |
|--------------------------------------------------------------------------|----------------------------------|--------------------------------|-----------------------------|------|------|
| | Claims Remaining After Amendment | Highest Number Previously Paid | Number Extra Claims Present | Rate | |
| Total Claims | 66 | - 77 = | | x | 0.00 |
| Independent Claims | 4 | - 5 = | | x | 0.00 |
| Multiple Dependent Claims (check if applicable) <input type="checkbox"/> | | | | | |
| Other fee (please specify): | | | | | |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT: | | | | | 0.00 |

 Large Entity Small Entity No additional fee is required for this amendment. Please charge Deposit Account No. _____ in the amount of \$ _____.
A duplicate copy of this sheet is enclosed. A check in the amount of \$ _____ to cover the filing fee is enclosed. Payment by credit card. Form PTO-2038 is attached. The Commissioner is hereby authorized to charge and credit Deposit Account No. 04-1073 as described below. A duplicate copy of this sheet is enclosed. Credit any overpayment. Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

 Thomas J. D'Amico
 Attorney Reg. No.: 28,371

Dated: April 30, 2003

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Docket No.: M4065.0466/P466
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Neal Rueger

Application No.: 09/938,644

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Group Art Unit: 1765

Filed: August 27, 2001

Examiner: T. Mackey

For: METHOD AND APPARATUS FOR
MICROMACHINING USING A MAGNETIC
FIELD AND PLASMA ETCHING

AMENDMENT

Box Non-Fee Amendment
Commissioner for Patents
Washington, DC 20231

Dear Sir:

In response to the Office Action dated February 5, 2003 (Paper No. 4), please amend the above-identified U.S. patent application as follows:

In the Claims: amendments to the claims are as shown beginning at page 2.

Please consider the **Remarks**, which begin at page 11.